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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/648,111	08/25/2000	Kwang-Jo Hwang	3430-0131P	5562
<div>7590 01/27/2009 Birch Stewart Kolasch & Birch LLP PO BOX 747 Falls Church, VA 22040-0747</div>				
			EXAMINER WILSON, ALLAN R	
			ART UNIT 2815	PAPER NUMBER
			MAIL DATE 01/27/2009	DELIVERY MODE PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.



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1/12/2009

BIRCH STEWART KOLASAH & BIRCH LLP
P.O. BOX 747
FALLS CHURCH, VA 22040-0747

In re Application of: :
Hwang, Kwang-Jo :
Serial No.: 09/648111 :
Filed: August 25, 2000 :
For: METHOD OF PATTERNING A METAL :
LAYER IN A SEMICONDUCTOR DEVICE :

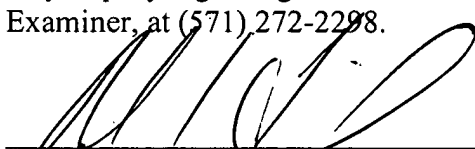
DECISION *SUA SPONTE*
WITHDRAWING HOLDING
OF ABANDONMENT

This is a decision, *sua sponte*, withdrawing the holding of abandonment of the above-identified application.

A decision denying a request for rehearing was mailed on November 13, 2008. The time for filing an appeal or commencing a civil action under 37 CFR 1.304 expires after two months. The application was held abandoned and a Notice of Abandonment was mailed on November 26, 2008.

Although no petition or request to withdraw the holding of abandonment in this application has been filed, the Notice of Abandonment is hereby vacated, the holding of abandonment withdrawn and the application restored to pending status. In view of the fact notice of abandonment was mailed prior to the expiration of the two month time period set in 37 CFR 1.304, the application is not abandoned in fact. Inconvenience to the applicant is regretted.

Any inquiry regarding this decision should be directed to Kenneth Parker, Supervisory Patent Examiner, at (571) 272-2298.


Richard K. Seidel, TC Director
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Semiconductors, Electrical and Optical
Systems and Components